

PATENT
MIC04 P-106

VIA FACSIMILE 1-703- 872-9310

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : George A. Goudreau
Group : 1763
Confirmation No. : 4253
Applicant : Imad Mahawili, PhD
Serial No. : 09/488,309
Filed : January 20, 2000
For : REACTOR WITH REMOTE PLASMA SYSTEM AND
METHOD OF PROCESSING A SEMICONDUCTOR
SUBSTRATE

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

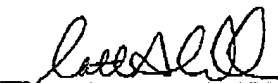
CERTIFICATE OF FACSIMILE TRANSMISSION

I HEREBY CERTIFY that on September 19, 2002, the below-listed items are
being forwarded by facsimile transmission to BOX RESPONSE - NO FEE, Commissioner
for Patents, Washington, D.C., 20231, via facsimile number 1-703-872-9310:

1. Response and Appendix (19 pages), and Attachment
thereto (3 pages); and
2. Certificate of Facsimile Transmission.

The total amount of pages being forwarded by facsimile transmission is
23 pages.

Dated: September 19, 2002


Catherine S. Collins
Registration No. 37 599
VAN DYKE, GARDNER,
LINN & BURKHART, LLP
P.O. Box 888695
2851 Charlevoix Drive, S.E.
Grand Rapids, Michigan 49588-8695
(616) 975-5500

FAX RECEIVED
SEP 19 2002
GROUP 1700
OFFICIAL